



IFW

2812

03500.017731.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
HIDEYA KUMOMI ET AL.) Examiner: Michael Lebentritt
Application No.: 10/533,091) Group Art Unit: 2812
Filed: April 28, 2005)
For: PRODUCING METHOD FOR)
CRYSTALLINE THIN FILM) August 29, 2006

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed foreign documents and articles are also enclosed.

The concise explanation of relevance for the non-English document is found in the specification where cited, and in an attached abstract.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that an initialed copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

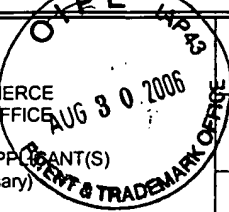
Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

A handwritten signature in dark ink, appearing to read "Peter Saxon", written over a horizontal line.

Peter Saxon
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FORM PTO 1449 (modified)				ATTY DOCKET NO. 03500.017731.		APPLICATION NO. 10/533,091	
U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE				APPLICANT HIDEYA KUMOMI, ET AL.			
LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)				FILING DATE April 28, 2005		GROUP 2812	
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		5,130,103	07/14/92	Yamagata et al.	428	209	
		5,207,863	05/04/93	Kumomi	156	603	
		5,290,712	03/01/94	Sato, et al.	437	24	
		5,723,348	03/03/98	Kumomi et al.	437	23	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
	JP	8-8197	01/12/96	Japan			Abstract
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
		Kumomi, et al. "Selective Nucleation-based Epitaxy (SENTAXY): A novel Approach for Thin Film Formation"; JPN J. Appl. Phys., Vol. 36 pp 1383-1388 (1997).					
		Kumomi, et al. "Fundamentals for the Formation and Structure Control of Thin Films: Nucleation, Growth, Solid-state Transformations"; Handbook of Thin Film Materials, Vol. 7, Ch. 6, pp 319-373 (2002).					
		Hatano, et al. "Excimer Laser-induced Temperature Field in Melting and Resolidification of Silicon Thin Films"; J. Appl. Phys., Vol. 87, No. 1, pp. 36-43 (2000).					
		Van der Wilt, et al. "Formation of Location-controlled Crystalline Islands Using Substrate-embedded Seeds in Excimer-laser Crystallization of Silicon Films"; Appl. Phys. Lett, Vol. 79, No. 12, pp 1819-1821 (2001)					
EXAMINER				DATE CONSIDERED			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet 1 of 1